

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Thomas A. Figura et al.

Serial No.: 09/470,650

§
§ Group Art Unit: 2829
§
§ Examiner: Lisa Kilday
§
§ Atty. Docket: 94-0280.04
§
§
§

Filed: December 22, 1999

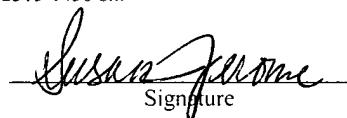
Title: USE OF A PLASMA SOURCE TO FORM A LAYER
DURING THE FORMATION OF A SEMICONDUCTOR DEVICE

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

"Certificate of Mailing"

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

Date 11/5/03


Signature

Dear Sir:

Applicants herein respond to the Office Action dated October 8, 2003. Please amend the above-captioned application as follows.